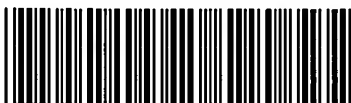


Search Notes

Application/Control No.

10/613,057

Examiner

Christopher P. Schwartz

Applicant(s)/Patent under
Reexamination

ZIEROLF, MICHAEL LEE

Art Unit

3683

SEARCHED

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES
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